

JAN-15-2004 17:02

SUGHRUE MION

RECEIVED
CENTRAL FAX CENTER

202 293 7860 P.01

2100 Pennsylvania Avenue, NW
Washington, DC 20037-3213

T 202.293.7060
F 202.293.7860

www.sughrue.com



JAN 15 2004

OFFICIAL

FAX

Date January 15, 2004

To Examiner Erin M. Gill

Of USPTO Group Art Unit 2881

Fax 703-872-9306
703-746-9311

From Alan J. Kasper

Subject Previously Submitted Amendment

Our Ref Q59993 Your Ref 09/606,679

Pages 25 24
(including cover sheet)

Please call attention to problems with this transmission by return fax or telephone. Thank you.

THE INFORMATION CONTAINED IN THIS COMMUNICATION IS CONFIDENTIAL, MAY BE ATTORNEY-CLIENT PRIVILEGED, AND IS INTENDED ONLY FOR THE USE OF THE ADDRESSEE. UNAUTHORIZED USE, DISCLOSURE OR COPYING IS STRICTLY PROHIBITED AND MAY BE UNLAWFUL. IF YOU HAVE RECEIVED THIS COMMUNICATION IN ERROR, PLEASE IMMEDIATELY NOTIFY US.

Dear Examiner Gill,

Per your request, attached is a copy of an amendment that was filed on August 7, 2003 together with a copy of the check for \$110.00 and the mail room stamped receipt dated August 7, 2003, listing both the payment and the amendment. Please advise if you need anything more.

Respects, Alan Kasper (Reg. 25,426)

FILING RECEIPT
PLEASE DATE STAMP AND RETURN TO US - BOX 235X

In re application of

Isao AMEMIYA

Appln. No.: 09/606,679

Confirmation No.: 8440

Filed: June 30, 2000



Group Art Unit: 2881

Examiner: Erin M. Gill

For: ELECTRON BEAM DRAWING MASK BLANK, ELECTRON BEAM DRAWING MASK, AND
METHOD OF MANUFACTURING THE SAME

PAPER(S) FILED ENTITLED:

1. Amendment Under 37 C.F.R. §1.111
2. Petition for Extension of Time (in duplicate with Check No. 228025
in the amount of \$110.00).

SUGHRUE MION, PLLC
Telephone: (202) 293-7060
Facsimile: (202) 293-7860

DOCKET NO.: Q59993
ATTORNEY/SEC: AJK/prc
Date Filed: August 7, 2003

WASHINGTON OFFICE

23373

CUSTOMER NUMBER

**RECEIVED
CENTRAL FAX CENTER**

JAN-15-2004 17:02

SUGHRUE MION

JAN 15 2004

202 293 7860 P.03

OFFICIAL

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q59993

Isao AMEMIYA

Appln. No.: 09/606,679

Group Art Unit: 2881

Confirmation No.: 8440

Examiner: Erin M. Gill

Filed: June 30, 2000

For: ELECTRON BEAM DRAWING MASK BLANK, ELECTRON BEAM DRAWING
MASK, AND METHOD OF MANUFACTURING THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

FILED

AUG - 7 2003

Sir:

In response to the Office Action dated April 10, 2003, please amend the above-identified application as follows on the accompanying pages.